

JFW

Attorney Docket 0553-0393



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Re Application of )  
)  
Shunpei Yamazaki et al. )  
)  
Serial No.: 10/757,167 )  
)  
Filed: January 13, 2004 )  
)  
For: Method Of Manufacturing )  
Semiconductor Device (as amended) )  
)  
Art Unit: 2822 )  
)  
Examiner: Christy L. Novacek )

I hereby certify that this correspondence is being deposited  
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Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace  
Signature

5/30/06

Date

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT D**

Sir:

In response to the Office Action of February 28, 2006, please amend the above-identified  
application as follows: